

GAU 2811



Docket: 0756-1930

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of )  
Shunpei YAMAZAKI et al. )  
Serial No. 09/239,948 ) Art Unit: 2811  
Filed: January 29, 1999 ) Examiner: G. Munson  
For: LASER PROCESSING METHOD, )  
METHOD FOR FORMING A FLASH )  
MEMORY, INSULATED GATE )  
SEMICONDUCTOR DEVICE, AND )  
METHOD FOR FORMING THE SAME )

RECEIVED  
JUN 30 2000  
TECHNOLOGY CENTER 2800

Honorable Assistant Commissioner of Patents  
Washington, D.C. 20231

Sir:


Transmitted herewith is an Amendment in the above-identified application.

- [ X ] No additional fee is required.
- [ X ] In the event applicant(s) has overlooked the need for any petition to effect the entry of the documents submitted herewith, it is respectfully requested that this be treated as such petition and that any necessary fees associated with this petition be charged to Deposit Account No. 19-2380.
- [ X ] In the event applicant(s) has overlooked the need for any petition and fee for extension of time, and such extension is required, applicant(s) requests that this be considered a petition therefor and that such fee be charged to Deposit Account No. 19-2380.
- [ X ] The Commissioner is hereby authorized to charge fees under 37 CFR 1.16, 1.17, 1.20(a), 1.20(b), 1.20(c) and 1.20 (d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment, to Deposit Account No. 19-2380. A duplicate copy of this sheet is attached.

Respectfully submitted,

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on 6-28-00

  
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McLean, Virginia 22102  
(703) 790-9110



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Docket: 0756-1930

RESPONSE UNDER 37 CFR 1.116 -  
EXPEDITED PROCEDURE -  
EXAMINING GROUP 2811

*#9/D (ad)*  
*9/5/00*  
*Jurley*

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*Rose M Fichtel*  
Rose M. Fichtel

AMENDMENT

Honorable Assistant Commissioner of Patents

Washington, D.C. 20231

Sir:

Please amend the above-identified application as follows:

*ok to*  
*enter*  
*2/2/01*  
*8 Sept 2000*